IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Gi-Jung Kim et al. Serial No. 10/601,475

Filed: June 23, 2003

Confirmation No. 7249 Group Art Unit: 1775

Examiner: Elizabeth D. Ivey

For: SEMICONDUCTOR WAFERS HAVING ASYMMETRIC EDGE PROFILES

THAT FACILITATE HIGH YIELD PROCESSING BY INHIBITING

PARTICULATE CONTAMINATION AND METHODS OF FORMING SAME

July 31, 2006

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1451

RESPONSE TO NOTICE OF NON-RESPONSIVE AMENDMENT

Sir:

Applicants respectfully submit that Applicants' Amendment A of May 1, 2006 is fully responsive to the Official Action of February 3, 2006. In this Amendment A, Claims 11-14, which were the only claims subject to prior art rejections, were canceled. Accordingly, Applicants' remarks did not need to address the prior art rejections when Applicants' Amendment A was filed.

Based on these comments, Applicants respectfully request entry of the Amendment A of May 1, 2006 and further examination of the present application.

Respectfully submitted,

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CERTIFICATION OF ELECTRONIC TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically to the U.S. Patent and Trademark Office on July 31, 2006.

Candi L. Riggs

#522510